



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 24, 2025

IGI Report Number **LG760556885**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **11.97 x 8.09 x 5.04 mm**

GRADING RESULTS

Carat Weight **3.06 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

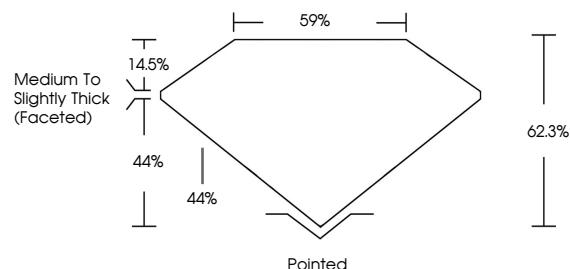
Fluorescence **NONE**

Inscription(s) **IGI LG760556885**

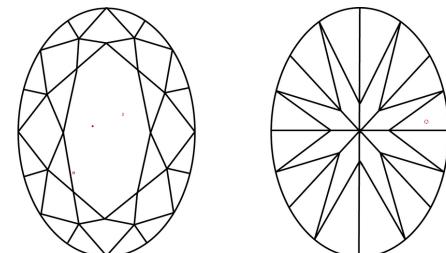
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

www.igi.org

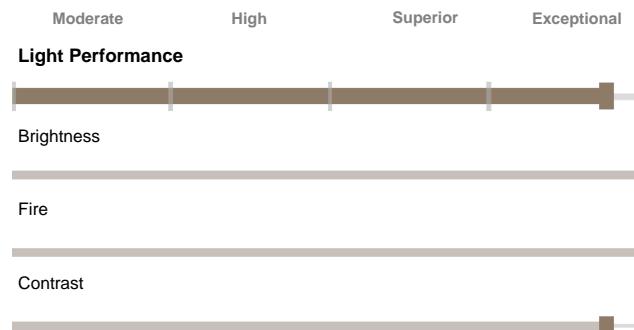
LG760556885
Report verification at igi.org

LIGHT PERFORMANCE REPORT

Light Performance Grade: **Exceptional**



Structured Light Environment Representation



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

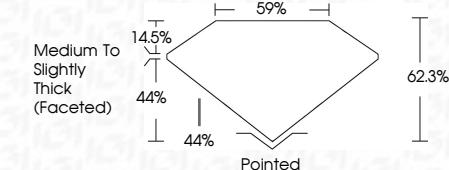
Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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IGI

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IGI Report No **LG760556885**
OVAL BRILLIANT
11.97 x 8.09 x 5.04 MM
3.06 CARATS
Color Grade **E**
Clarity Grade **VS 1**
Depth Grade **62.3%**
Table Grade **59%**
Medium To Slightly Thick (Faceted)
Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG760556885

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Type IIa